

AMENDMENTS TO THE CLAIMS:

This listing of claims will replace all prior versions, and listings, of claims in the application:

1 – 10 Cancelled

11. (Previously Presented): An outgas collection method comprising the steps of:

 holding, at a lower side of an exposure chamber under vacuum, a substrate on which a resist film is formed;

 irradiating said resist film with an electron beam provided from an electron beam source placed at an upper side of said exposure chamber;

 collecting an outgas at a collection unit connected to said exposure chamber; and

 absorbing said outgas at said collection unit,

 wherein said outgas is released from said resist film when said resist film is irradiated with said electron beam.

12. (Previously Presented): The outgas collection method of claim 11, wherein said collection unit has an absorption agent.

13. (Previously Presented): An outgas analysis method comprising the steps of:
 holding, at a lower side of an exposure chamber under vacuum, a substrate on which a resist film is formed;

 irradiating said resist film with an electron beam provided from an electron beam

source placed at an upper side of said exposure chamber;

collecting an outgas at a collection unit connected to said exposure chamber;

absorbing said outgas at said collection unit; and

analyzing a plurality of constituents of absorbed outgas at an analysis unit connected to said collection unit,

wherein said outgas is released from said resist film when said resist film is irradiated with said electron beam.

14. (Previously Presented): The outgas analysis method of claim 13, wherein said collection has an absorption agent.

15. (Previously Presented): The outgas analysis method of claim 13, wherein said plurality of constituents of said outgas are analyzed by a gas chromatograph mass spectrometer.

16. (Previously Presented): The outgas analysis method of claim 13, wherein said outgas is absorbed in an activated carbon placed in said collection unit, and said plurality of constituents are released from said outgas by heating said activated carbon after collecting and before analyzing.

17. (Previously Presented): An outgas analysis method comprising the steps of: holding, at a lower side of an exposure chamber under vacuum, a substrate on which a resist film is formed;

irradiating said resist film with an electron beam provided from an electron beam source placed at an upper side of said exposure chamber; and
analyzing a plurality of constituents of an outgas,
wherein said outgas is released from said resist film when said resist film is irradiated with said electron beam.

18. (Previously Presented): The outgas analysis method of claim 17, wherein said plurality of constituents of said outgas are analyzed by a gas chromatograph mass spectrometer.

19 - 21 Cancel

22. (Previously Presented): An electron beam aligner comprising:
an exposure chamber;
a substrate holder placed in a lower side of said exposure chamber under vacuum;
a substrate having a resist film, placed on said substrate holder;
a collection unit connected to said exposure chamber; and
an analysis unit connected to said exposure chamber,
wherein an outgas released from said resist film when said resist film is irradiated with said electron beam is collected at said collection unit, and
a plurality of constituents of said outgas are analyzed at said analysis unit.

23. (Previously Presented): The electron beam aligner of claim 22, wherein said

collection unit has an absorption agent.

24. (Previously Presented): The electron beam aligner of claim 22, wherein said analysis unit has a gas chromatograph mass spectrometer.

25. (Previously Presented): The electron beam aligner of claim 22, wherein said outgas includes isobutene.

26. (Previously Presented): An electron beam aligner comprising:
an exposure chamber;
a substrate holder placed in a lower side of said exposure chamber under vacuum;
a substrate having a resist film, placed on said substrate holder;
an electron beam source placed at an upper side of said exposure chamber; and
an analysis unit connected to said exposure chamber,
wherein a plurality of constituents of an outgas released from said resist film when said resist film is irradiated with said electron beam are analysis at said analysis unit.

27. (Previously Presented): The electron beam aligner of claim 26, wherein said collection unit has an absorption agent.

28. (Previously Presented): The electron beam aligner of claim 26, wherein said analysis unit has a gas chromatograph mass spectrometer.

29. (Previously Presented): The electron beam aligner of claim 26, wherein said outgas includes isobutene.